



2828

PATENT  
83371.0002

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hideo SHIOZAWA, et al.

Serial No: 09/990,671

Filed: November 15, 2001

For: SEMICONDUCTOR LASER, METHOD  
FOR FABRICATING THEREOF, AND  
METHOD FOR MOUNTING THEREOF

Art Unit: 2828

Examiner: James W. Davie

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Anthony J. Orler, Reg. No. 41,232

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**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement dated September 29, 2003, Applicant elects  
for prosecution the claims of Group I, Claims 1-8 and 10 without traverse.

If there are any fees due in connection with the filing of this response, please charge the  
fees to our Deposit Account No. 50-1314.

Respectfully submitted,

HOGAN &amp; HARTSON L.L.P.

Date: October 28, 2003

By:

Anthony J. Orler

Registration No. 41,232

Attorney for Applicant(s)

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